



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 3, 2024	
IGI Report Number	LG655458941
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	11.28 X 8.17 X 5.54 MM

GRADING RESULTS

Carat Weight	5.02 CARATS
Color Grade	F
Clarity Grade	VVS 2

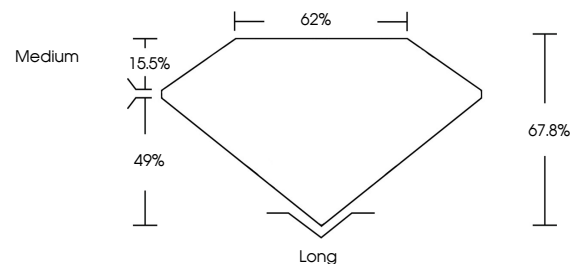
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG655458941

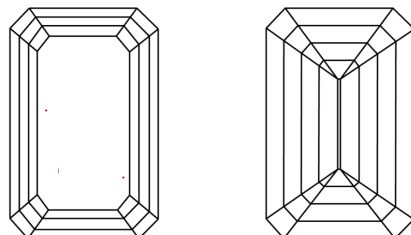
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG655458941
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

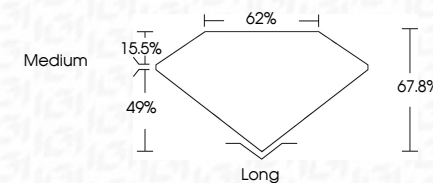
IF	VVS ^{1,2}	VS ^{1,2}	SI ^{1,2}	I ^{1,3}
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG65545894
<p>Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.</p> <p>Type IIa</p>	



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October 3, 2024
 IGI Report No LG655458941
 EVERALD CIT

11.28 X 6.17 X 5.54 MM	Carat Weight	5.02 CARATS
	Color Grade	F
	Clarity Grade	VVS 2
	Depth	67.8%
	Table	62%
	Girdle	Medium
	Culet	Long
	Polish	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE

Comments:
This Laboratory Grown Diamond was
created by Chemical Vapor Deposition
(CVD) growth process.